

Notice of References Cited	Application/Control No. 10/011,022	Applicant(s)/Patent Under Reexamination VANDERSLUIJ, KIRSTAN AND	
	Examiner David Y. Jung	Art Unit 2134	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Requirements engineering process improvement based on an information model Doerr, J.; Paech, B.; Koehler, M.; Requirements Engineering Conference, 2004. Proceedings. 12th IEEE International 2004 Page(s):70 - 79
	V	Develop an intelligent equipment maintenance system using cyber-enabled JESS technology Yin-Ho Hao; Trappey, A.J.C.; Ku, C.C.; Lin, G.Y.P.; Ho, P.-S.; Hung, B.; Mechatronics, 2005. ICM '05. IEEE International Conference on 10-12 July 2005 Page(s):927 - 932
	W	On rethinking organizational document genres for electronic document management Tyrvaenen, P.; Paivarinta, T.; System Sciences, 1999. HICSS-32. Proceedings of the 32nd Annual Hawaii International Conference on Volume Track2, 5-8 Jan. 1999 Page(s):10 pp.
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.